	ı
*	ı
	ı

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/710,887	LIU ET AL.	
Examiner	Art Unit	
W. Patty Chen	2871	

SEARCHED				
Class	Subclass	Date	Examiner	
349	129	6/1/2006	WPC	
	<u> </u>			
-				

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
349/139 combined with key words search of all databases in EAST	6/2/2006	WPC	
class 349 combined with key words search of all databases in EAST	6/2/2006	WPC	